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RESPONSE UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE REQUESTED  
EXAMINING GROUP 2891

PATENT  
Customer No. 22,852  
Attorney Docket No. 02887.0259

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
	)	
Junji SUGAMOTO et al.	)	Group Art Unit: 2891
	)	
Application No. 10/706,090	)	Examiner: Smith, Bradley
	)	
Filed: November 13, 2003	)	
	)	
For: SEMICONDUCTOR WAFER	)	Confirmation No. 7292
TREATMENT METHOD,	)	
SEMICONDUCTOR WAFER	)	
INSPECTION METHOD,	)	
SEMICONDUCTOR DEVICE	)	
DEVELOPMENT METHOD AND	)	
SEMICONDUCTOR WAFER	)	
TREATMENT APPARATUS	)	

**Mailstop AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**AMENDMENT AFTER FINAL**

In reply to the Office Action mailed January 25, 2007, the period for response to which extends through April 25, 2007, and pursuant to 37 C.F.R. § 1.116, Applicants propose that this application be amended as follows:

**Amendments to the Claims** are reflected in the listing of claims in this paper.

**Remarks/Arguments** follow the amendment section of this paper.